Corrigendum

Sub: Request for Quote for procurement of an epitaxial CVD system for Si, SiGe and Ge Epitaxial CVD Systems

Ref: Advertisement for RFQ (Request for Quote) document for procurement of an epitaxial CVD system along with attachments posted on 9th July.

The following corrigendum is issued in the above matter:

<table>
<thead>
<tr>
<th>Existing</th>
<th>Modified as</th>
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<tbody>
<tr>
<td>The <strong>deadline for submission of proposals is the 26th of July 2018, 5:30 pm Indian Standard Time.</strong></td>
<td>The <strong>deadline for submission of proposals is the 3rd of August 2018, 5:30 pm Indian Standard Time.</strong></td>
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</tbody>
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Any questions or clarifications can be directed to:
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